

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shinji MAEKAWA et al.)
Application No. 10/575,492) Art Unit: 2812
Filed: April 12, 2006) Confirmation No. 3788
For: METHOD FOR FORMING WIRING, METHOD)
FOR MANUFACTURING THIN FILM TRANSISTOR)
AND DROPLET DISCHARGING METHOD)

CORRECTED INFORMATION DISCLOSURE STATEMENT

United States Patent and Trademark Office
Customer Window, Mail Stop AMENDMENT
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Applicants noted errors in the PTO Form-1449 that was filed June 30, 2010. Specifically, the publication date was inserted rather than the issue date for each of the issued patents.

In order to correct these errors, Applicants enclose a new Form PTO-1449. Applicants respectfully request the Examiner to initial and date the enclosed Form PTO-1449 to indicate consideration of these references, and to mark through the entries on the PTO-1449 filed on June 30, 2010 having the publication date inserted rather than the issue date.

The Commissioner is hereby authorized to charge any fee required in connection with this filing, and any additional fees which may be required, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

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